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[10191/3702]

**UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Maria Del Rocio Martin Lopez et al.  
Serial No. : 10/501,287  
Filing Date : January 18, 2005  
For : SEMICONDUCTOR SYSTEM HAVING A PN  
TRANSITION AND METHOD FOR MANUFACTURING A  
SEMICONDUCTOR SYSTEM  
Group Art Unit : 2822  
Examiner : Tsz K. Chiu  
Confirmation No. : 5683

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Date: September 26, 2006

Signature:

Jong H. Lee (Reg. No. 36,197)

**RULE 116 AMENDMENT**

SIR:

In response to the final Office Action of July 7, 2006, please amend the above-captioned application without prejudice as follows.

**Amendments to the Claims** are found in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 3 of this paper.